



#17/IDS

00862.022171

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: K. Nguyen
Takayuki YAGI et al.)	
	:	Group Art Unit: 2881
Application No.: 09/819,672)	
	:	Confirmation No.: 3159
Filed: March 29, 2001)	
	:	Allowed: August 12, 2003
For: ELECTRON OPTICAL SYSTEM ARRAY,)	
CHARGED-PARTICLE BEAM EXPOSURE	:	November 6, 2003
APPARATUS USING THE SAME, AND)	
DEVICE MANUFACTURING METHOD	:	

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FOURTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:


Further to the Information Disclosure Statements filed on October 23, 2001, January 29, 2003, June 5, 2003, and August 7, 2003, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. Copies of the listed document and its English translation are also enclosed.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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